

Modeling in semiconductor electronics

Javor, A.; **Rang, Toomas**; Szekely, V.; Tamay, K.; **Velme, Enn** 1993 https://www.ester.ee/record=b1031052*est

Thermal activation and pozzolanic reactivity of Estonian clays for cementitious applications

Yörük, Can Rüstü; Adegbile, Ademola Michael; Tuisk, Tanel; Hain, Tiina; Uibu, Mai; Usta, Mustafa Cem; Trikkel, Andres

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